



2851

PATENT APPLICATION

#9

1-100-03

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In re the Application of

Batch/Confirmation No.: 4482

Hideki KOMATSUDA

Allowed: August 19, 2002

Application No.: 09/697,639

Group Art Unit: 2851

Filed: October 27, 2000

Examiner: R. Fuller

For: EXPOSURE APPARATUS AND METHOD OF FABRICATING A MICRO
DEVICE USING THE EXPOSURE APPARATUS

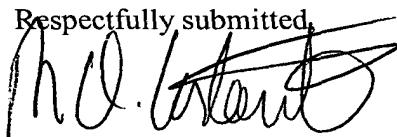
Docket No.: 105193.01

LETTER TO THE OFFICIAL DRAFTSPERSONDirector of the U.S. Patent and Trademark Office
Washington, D.C. 20231

Sir:

Please substitute the attached 27 sheets of formal drawings depicting Figures 1-27 for the corresponding drawings filed with the application. The attached drawings have been corrected pursuant to the Examiner's comment in the Notice of Allowance (Paper No. 7).

Respectfully submitted,


Mario A. Costantino

Registration No. 33,565

MAC/ccs

Date: September 18, 2002

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